Search Notes



Application/Control No. 10/501,690

Examiner

Applicant(s)/Patent under Reexamination ZHANG ET AL. Art Unit

Jason M. Nolan, Ph.D.

1626

SEARCHED					
Class	Subclass	Date	Examiner		
549	43, 57, 350, 387, 433, 436	2/5/2006	JMN		
549	458	2/5/2006	JMN		
548	200, 236	2/5/2006	JMN		
544	405	2/5/2006	JMN		
546	83, 284.1	2/5/2006	JMN		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
544	405	2/5/2006	JMN		
546	83, 284.1	2/5/2006	JMN		
549	458	2/5/2006	JMN		
548, 514		2/5/2006	JMN		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Inventor Search - Double Patenting Review	2/15/2006	NML		
STN CAPLUS Structure Search, printout attached	2/5/2006	NML		
IDS Reviewed	2/5/2006	JMN		
Priority Documents Reviewed	2/5/2006	JMN		
BIB, Oath, Spec, Claims reviewed	2/5/2006	JMN		
Patentability Conference with SPE and Primary Examiners	2/28/2006	JMN		